

Notice of References Cited	Application/Control No. 10/538,787	Applicant(s)/Patent Under Reexamination HAUBS ET AL.	
	Examiner David K. O'Dell	Art Unit 1609	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-			
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	D	US-			
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	F	US-			
	G	US-			
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	J	US-			
	K	US-			
	L	US-			
	M	US-			

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	O	GB 1,172,557	12-1969	Great Britan	Schmidt et. al.	C 07 d 19/00
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NON-PATENT DOCUMENTS

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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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